

# **Differential Deposition Figure Correction for**

## **X-ray Optics**

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## **Differential Deposition**



### • <u>What</u>

- Differential deposition is a technique for correcting figure errors in optics
- <u>How</u>
  - Use physical vapor deposition to selectively deposit material on the mirror surface to smooth out figure imperfections
- <u>Why</u>
  - Can be used on *any type* of optic, full-shell or segmented, mounted or unmounted
  - Can be used to correct a wide range of spatial errors. Could be used in conjunction with other techniques... e.g. active optics.
  - Technique has been used by various groups working on synchrotron optics to achieve sub-µradian-level slope errors







## **Process Sequence - Differential Deposition**











Simulated correction sequence showing parabolic axial figure profile before (top left) and after 3 stages of correction using a beam of FWHM = 14mm, 5.2 mm and 1.7 mm respectively. The dotted line gives the desired figure and the solid line gives the figure obtained at each stage. Overall, resolution improved from 7.8 arcsec to 0.9 arcsec HEW (2 bounce equivalent).



### **Heritage-Technique Used for Synchrotron Optics**



Optic undergoing metrology



### Figure errors after differential coating runs



#### From:

A preferential coating technique for fabricating large, high quality optics

S.G. Alcock, S. Cockerton,

NIM A 616, 2010





### **Proof of concept on miniature optics**



Modify an old coating chamber



Miniature medical optics



Slope improvement from 12 to 7 arcsec rms





### **Possible Practical Limitations We Are Addressing**

- Variation of sputtered beam profile along the length of mirror particularly for short focal length mirrors – Model and correct
- Deviation in the simulated sputtered beam profile from actual profile, beam nonuniformities, etc. – Quantify and correct
- Positional inaccuracy of the slit with respect to mirror Model effects to derive requirements
- Metrology uncertainty Upgrade metrology system
- Stress effects Quantify and control stress







Vertical chamber for segmented optics

Horizontal chamber for 0.25-m-scale full shell optics



### **Coating Systems**



Figure 2: Horizontal differential-deposition chamber



**Figure 3:** Sputtering head with copper mask positioned inside shell



### **Coating Systems**





Vertical deposition chamber





### **New Coating Systems – Test Coatings**







Simulations show that for full shell optic need < 10MPa stress to get < 1 arcsec optic. Set up dedicated system to characterize coating stresses.





Preliminary measurements showing coating stress versus deposition rate at fixed gas pressure. Inset shows stress versus coating thickness (nm) at fixed deposition rate





We are upgrading our vertical long-trace profilometer with new computer system and software provided by collaborators at Lawrence Berkeley Laboratory. In progress.





#### Test coating run # 1: horizontal chamber, 150 mm diameter shell P-end, pre- and post- two stages of correction







#### Test coating run # 2: horizontal chamber, 150 mm diameter shell P-end, pre- and post- 2 stages of correction







### **Differential Deposition – Top Challenges**

• Metrology on the inside of the thin shells is very challenging. For 2 stages of correction need to get reliable and repeatable metrology to 10's Angstrom. Removing and mounting the thin shells for metrology is a tricky business. In-situ metrology, planned in current APRA proposal, would significantly improve matters.

• Stress remains a concern. We believe we can obtain very-low-stress coatings, but have to demonstrate that the differential deposition chambers can give similar stresses to the stress characterization chamber (as coating conditions change). As an aside it may be possible to use a thin layer of a stressed coating to change the figure instead of filling it in. We are also investigating this.





### **Full Shell Direct Fabrication**

- Lighter-weight Chandra approach to x-ray optics .... preserves the inherent stiffness of full-shell geometry.
- Use new developments in computer-controlled polishing machines to directly fabricate a thinshell optic
- Goal is to demonstrate 5 arcsec resolution in 2 years, then explore what limits may be possible



ZEEKO polishing machine at MSFC

### **Full-Shell Direct Fabrication**

#### **PLAN**

- Demonstrate capability with 'thick' (~ 6 mm) shell first
  - Gain experience with ZEEKO machine (in process)
  - $\bullet$  Grind glass shell ready for ZEEKO machine  $\clubsuit$
  - Fabricate fixturing for polishing shell ا
  - Fabricate fixturing for metrology of shell  $\clubsuit$
- Move to thin shells (2-3 mm)
  - Develop polishing fixtures (in process)
  - Develop metrology fixtures (in process)
- Candidate materials
  - Start with glass (pyrex, fused silica)
  - Also investigate Be and AlSi alloys









### **Full Shell Direct Fabrication**



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**Challenge:** Supporting glass during fabrication ... the glass can easily be broken by polishing stresses

Table below shows results of finite element analysis of a simply-supported glass shell being polished with a bonnet force of 1N (~ 100g). Stress is given for 9 positions along shell length. Working strength of fused silica is just 7 MPa !

Position	Stress 6 mm shell MPa	Displacement 6 mm shell Micron	Stress 2 mm shell MPa	Displacement 2 mm shell Micron	1 HEAK, SKULTURI 1702-1 1702-1 1705-2 1705
1	1.2	0.02	11	0.3	
2	4.4	1.0	25	14	0 259466 518936 778404 11
3	3.7	1.7	25	19	NUOS_BUIDS_ENDOLERS
4	4.0	2.2	27	24	2018 -1 TUB9-1 UX TOF-0 D66 -43222-06 D66 -43222-06 D66 -4322-06 D66 -4322-06 D66 -4322-06 D66 -4322-06
5	4.5	2.9	31	31	
6	4.9	3.5	34	38	
7	5.2	4.4	36	48	-198-65 -,1389-65 -,568-66 ,1798-66 - 7 20.053_80.005_280-013p
8	5.4	5.2	37	58	
9	6.1	7.5	42	82	



### **Full Shell Direct Fabrication**



Solution: Support glass over whole length during fabrication

Multiple contact points would reduce stress but could lead to print-through. Use a support 'fluid' to restrain thin shell while under fabrication







### **Full-Shell Direct Fabrication**



**Challenge:** Supporting glass during metrology

Need to know the true figure of the shell. Polishing fixture will distort shell at some level. **Solution:** to use a metrology mount that preserves the native shell figure (mount is termed a 'whiffle tree').







### **Direct Fabrication – Current Status**

#### **Thick Shell**

- All fixturing has been completed and we are ready to start thick shell fabrication **Thin shell**
- Designs for fixturing for metrology and polishing are nearing completion

